

UNITED STATES DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

PATENT

In the application:

Inventors: HE, Ting et al.
Serial Number: 10/757,302
Filed: January 14, 2004

For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM
FOR MATERIAL COMBINATORIAL STUDIES

Group Art Unit 1763
Examiner Richard R. Bueker

Atty. Docket No.: 3994994-148069 CONFIRMATION NO. 4457

Amendment and Response to the Final Rejection Mailed on March 18, 2010

By *E-file [registered user]* on APRIL 30, 2010
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

To the Honorable Commissioner:

In response To the Final Rejection Mailed on March 18, 2010, entry of this amendment, reexamination and reconsideration is requested.

- 1) Amendments to the Drawings begin on page 2;
- 2) Amendments to the Claims begin on page 3; and
- 3) Remarks begin on page 7.

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